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OFFICE OF PETITIONS

Docket No.: 9323.055.00-US
(PATENT)

DAG 2
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
In-Kwon Jeong

Confirmation No.: 6430

Application No.: 09/828,029

Art Unit: 3743

Filed: April 6, 2001

Examiner: L. V. Ciric

For: MULTI-CHANNEL TEMPERATURE
CONTROL SYSTEM FOR SEMICONDUCTOR
PROCESSING FACILITIES

Customer No.: 30827

AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In response to the Office Action dated July 31, 2002, please amend the above-identified U.S. patent application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Amendments to the Abstract begin on page 15 of this paper.

Remarks/Arguments begin on page 16 of this paper.

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